

LIST OF REFERENCES CITED BY APPLICANT (Use several sheets if necessary)	ATTY DOCKET NO.	APPLICATION NO <b>10800221</b>
	060889-5002	To Be Assigned
	APPLICANT <b>McElheny and Liu</b>	
FILING DATE <b>Herewith</b>	GROUP To Be Assigned	

**U.S. PATENT DOCUMENTS**

*EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
WL	3,719,866	03-1973	Naber et al.	257	326	
WL	4,935,802	06-1990	Noguchi et al.	257	314	
WL	5,108,939	04-1992	Manley et al.	438	594	
WL	5,926,729	07-1999	Tsai et al.	438	591	
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WL	6,303,521	10-2001	Jenq	438	770	
WL	6,462,388	10-2002	Perner	257	390	

**FOREIGN PATENT DOCUMENTS**

	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION
						YES      NO

**OTHER REFERENCES (Including Author, Title, Date, Pertinent Pages, Etc.)**

WL	Fung, S., Chan, M., Ko, P., "Inverse-Narrow-Width Effect of Deep Sub-Micrometer Mosfets with Locos Isolation," Received 10/08/1996, Revised 03/17/1997, Solid State Electronics, Vol. 41, No. 12, pp. 1885-1889, 1997
WE	Wayne Wolf, "Modern VLSI Design, A System Approach," PTR Prentice Hall, Englewood Cliffs, New Jersey 07632, p. 29
WL	Imamiya et al., "MP 6.6, A 130mm <sup>2</sup> 256Mb NAND Flash with Shallow Trench Isolation Technology," 1999 IEEE International Solid-State Circuits Conference, 0-7803-5129/99, IEEE 1999

EXAMINER	<i>WL</i>	DATE CONSIDERED	<i>9/16/2004</i>
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\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.